

Practitioner's Docket No.: 811_107

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Makoto IWAI, Katsuhiro IMAI and Minoru IMAEDA

Ser. No.: 10/594,846

Group Art Unit: 1792

Filed: November 8, 2006

Examiner: Felisa Carla Hiteshew

Confirmation No.: 3664

For: GALLIUM NITRIDE SINGLE CRYSTAL GROWING METHOD AND
GALLIUM NITRIDE SINGLE CRYSTAL

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF EFS TRANSMISSION

I hereby certify that this paper is being transmitted via EFS to
the Patent and Trademark Office on *June 11, 2008*.


Janet M. Stevens

REQUEST FOR RECONSIDERATION

Sir:

In response to the Office Action mailed April 16, 2008, Applicants respectfully request reconsideration and withdrawal of the rejections of record based on the following arguments.

Claims 1-7 are pending herein.

Examiner Hiteshew is thanked for courtesies extended to Applicants' representatives during a telephonic interview on May 7, 2008. The substance of that interview has been incorporated into the following remarks.

1. Claims 1-7 were rejected under §103(a) over Kawamura. This rejection is respectfully traversed.